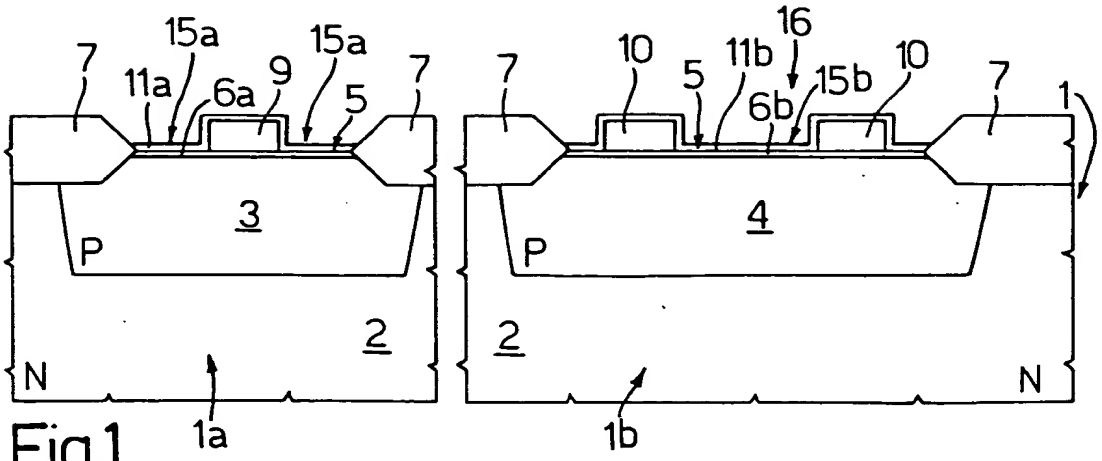

Fig.1

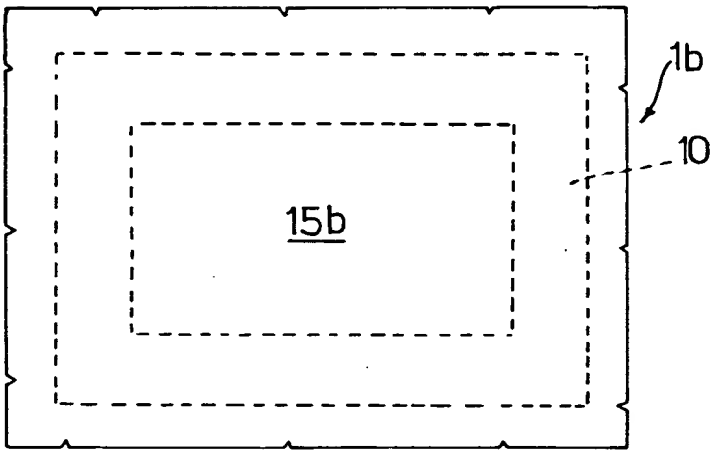

Fig.2

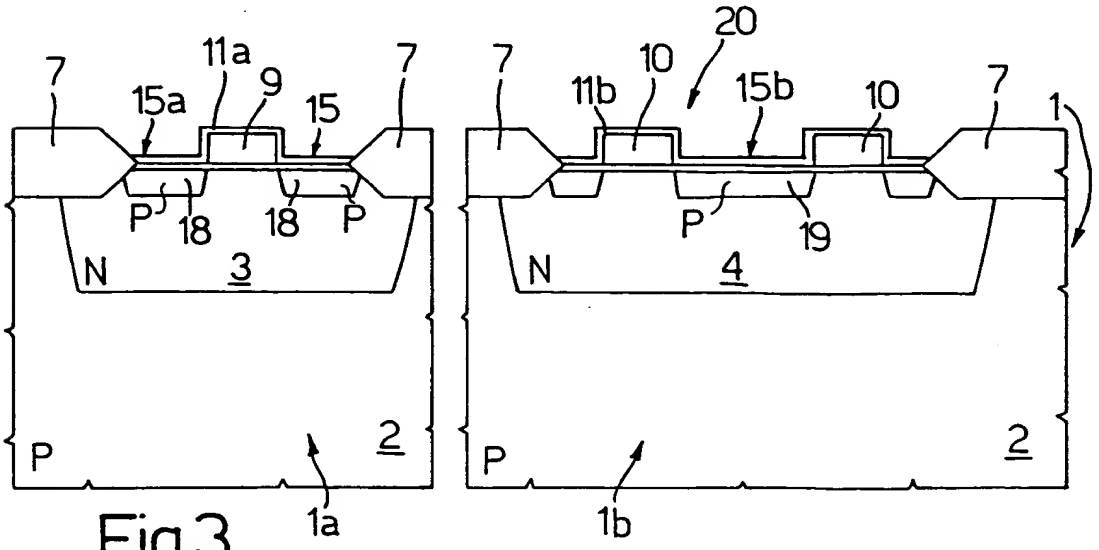

Fig.3

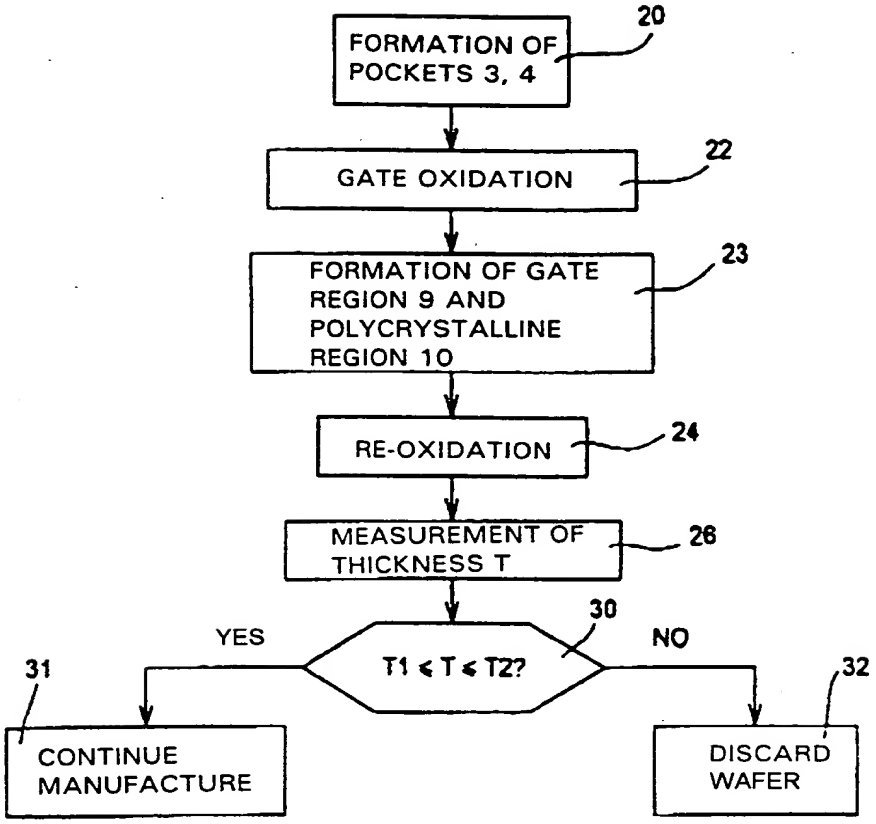
FORMATION OF POCKETS 3, 4
20
GATE OXIDATION
22
FORMATION OF GATE REGION 9 AND POLYCRYSTALLINE REGION 10
23
RE-OXIDATION
24
MEASUREMENT OF THICKNESS T
26
T1 ≤ T ≤ T2?
30
YES
NO
31
32
CONTINUE MANUFACTURE
DISCARD WAFER

FIG. 4